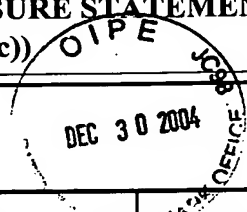


JFW

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
SEC.1040

In Re Application Of: **Jong-Rak Park et al.**



Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/623,616	07/22/2003	TBA	20987	2871	5049

Title: **PHOTOMASK HAVING A TRANSPARENCY-ADJUSTING LAYER, METHOD OF MANUFACTURING THE PHOTOMASK, AND EXPOSURE METHOD USING THE PHOTOMASK**

Address to:
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

37 CFR 1.97(b)

1. ☒ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

2. ☐ The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

☐ the statement specified in 37 CFR 1.97(e);

OR

☐ the fee set forth in 37 CFR 1.17(p).

3. ☒ Also enclosed is a copy of a Korean Notice to Submit Response dated 14 October 2004, which was issued in connection with Korean Application No. 10-2002-0061046.

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
SEC.1040

In Re Application: **Jong-Rak Park et al.**

DEC 30 2004

Application No. 10/623,616	Filing Date 07/22/2003	Examiner TBA	Customer No. 20987	Group Art Unit 2871	Confirmation No. 5049
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Title: **PHOTOMASK HAVING A TRANSPARENCY-ADJUSTING LAYER, METHOD OF MANUFACTURING THE PHOTOMASK, AND EXPOSURE METHOD USING THE PHOTOMASK**

Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

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- ☐ The Director is hereby authorized to charge and credit Deposit Account No. _____ as described below.
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